



DOCKET NO.: 3905

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE
IN THE MATTER OF THE APPLICATION FOR PATENT

OF: Takao NAKAMURA et al.

ART UNIT: 2814

SERIAL NO.: 09/519,408

Conf. No.: 7245

FILED: March 3, 2000

Ex.: W. S. Louie

FOR: Semiconductor Light-emitting Device,
Method of Manufacturing Transparent
Conductor Film and Method of Manufac-
turing Compound Semiconductor Light-
emitting Device

M.S. AF

COMMISSIONER FOR PATENTS

P.O. BOX 1450

ALEXANDRIA, VA 22313-1450

May 5 2003

RECEIVED
MAY 12 2003
TECHNOLOGY CENTER 2814

INFORMATION DISCLOSURE STATEMENT WITH CERTIFICATE OF MAILING

Dear Sir:

- 1) Pursuant to 37 C.F.R. §§ 1.56, 1.97 and 1.98 applicants enclose a Form PTO-1449, a copy of the reference listed thereon, and a copy of a Japanese Office Action (and English translation thereof) issued in a counterpart Japanese Priority application on March 25, 2003.
- 2) In accordance with 37 C.F.R. 1.97(d), this IDS is being filed before payment of the issue fee, includes the required certification (see next paragraph), and is accompanied by a Credit Card Payment Form (PTO-2038) to cover the required fee of \$180.00.
- 3) The undersigned attorney hereby certifies that each item of information contained in this Information Disclosure Statement was first cited in any communication from a foreign patent office in a counterpart foreign application not more than three months

05/09/2003 MGBREM1 00000021 09519408

02 FC:1806

180.00 OP

3905/WFF:ar

prior to the filing of this statement, as seen from the Japanese Office Action date of March 25, 2003.

- 4) The present reference AE2 is accompanied by an English Abstract. Moreover, the enclosed English translation of the Japanese Office Action shows why the Japanese Examiner found the cited reference to be relevant. The Japanese Examiner's remarks are not ratified or adopted as accurate, but are submitted for the U. S. Examiner's consideration as to the relevance of the reference.
- 5) Applicants respectfully request that the Examiner consider all references of record, return an initialled copy of the enclosed Form PTO-1449 and ensure that all references of record are printed on any patent issuing from this application.

Respectfully submitted,

Takao NAKAMURA et al.
Applicant

WFF:ar/3905
Enclosure: postcard,
Third Form PTO-1449,
1 reference,
copy of Japanese Office Action
with English translation,
Form PTO-2038

By Walter F. Fasse
Walter F. Fasse
Patent Attorney
Reg. No.: 36132
Tel. No.: 207-862-4671
Fax. No.: 207-862-4681
P. O. Box 726
Hampden, ME 04444-0726

CERTIFICATE OF MAILING:

I hereby certify that this correspondence with all indicated enclosures is being deposited with the U. S. Postal Service with sufficient postage as first-class mail, in an envelope addressed to: MS AF, COMMISSIONER FOR PATENTS, P.O. Box 1450, Arlington, VA, on the date indicated below. 22313-1450,

Anita Morse - May 5, 2003
Name: Anita Morse - Date: May 5, 2003

Sheet 1 of 1Atty. Docket No.
3905Serial No.:
09/519,408

SIXTH
LIST OF REFERENCES CITED BY
APPLICANT
(REVISED FORM PTO-1449)
DATED: May 5, 2003

Applicant: Takao NAKAMURA et al.

U.S. Filing Date:
March 3, 2000Art Unit:
2814

U. S. PATENT DOCUMENTS

*EXAMINER INITIAL	DOCUMENT NO.	DATE	NAME	Cl.	Sub- Cl.	File Date

FOREIGN PATENT DOCUMENTS

*EXAMINER INITIAL	DOCUMENT NO.	DATE	COUNTRY	Cl.	Sub- Cl.	Trans.	
						Yes	No
	AE2 09 2 3 2 6 3 3	09/1997	Japan	-	-	x- Abst.	

OTHER DOCUMENTS

EXAMINER	DATE CONSIDERED

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

TECHNOLOGY CENTER 2800

MAY 12 2003

RECEIVED